

Notice of References Cited	Application/Control No. 10/820,719	Applicant(s)/Patent Under Reexamination CHIU, CHOI	
	Examiner Jean A. Gelin	Art Unit 2688	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0221793	10-2005	Chin et al.	455/401
*	B	US-6,418,330	07-2002	Lee, Hyeon-Woo	455/567
*	C	US-2004/0032946	02-2004	Koser et al.	379/373.01
*	D	US-2004/0067751	04-2004	Vandermeijden et al.	455/414.1
*	E	US-2005/0107075	05-2005	Snyder, Thomas David	455/418
*	F	US-2005/0143054	06-2005	Fogel, Eliezer	455/415
*	G	US-2002/0058521	05-2002	Yamada et al.	455/458
*	H	US-2005/0164746	07-2005	Boyd, Martha Karen	455/567
*	I	US-2004/0235520	11-2004	Cadiz et al.	455/557
*	J	US-2004/0204146	10-2004	Deeds, Douglas	455/567
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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